

Long-term Operation of the Multi-Wire-Proportional-Chambers

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based on the paper: **F. P. Albicocco** *et al* 2019 *JINST* **14** P11031

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Phenomena in Gaseous Detectors

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Outlines

- ❑ General description of Muon LHCb infrastructure;
- ❑ Structure of MWPC;
- ❑ Operational and trip intro (What is the trip? Malter-like currents);
- ❑ The number of malfunctioned chambers during the Runs;
- ❑ A process of chamber curing/restoring;
- ❑ Result;

LHCb Muon System

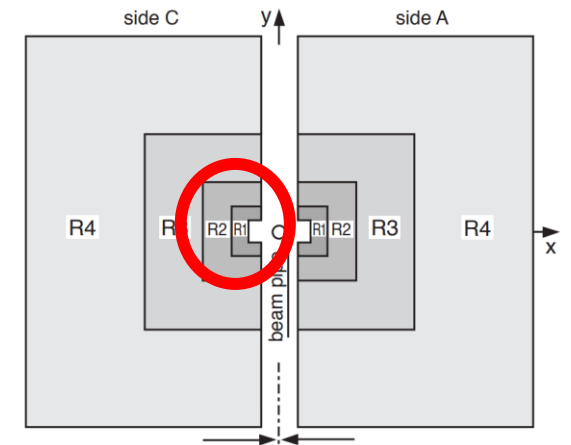
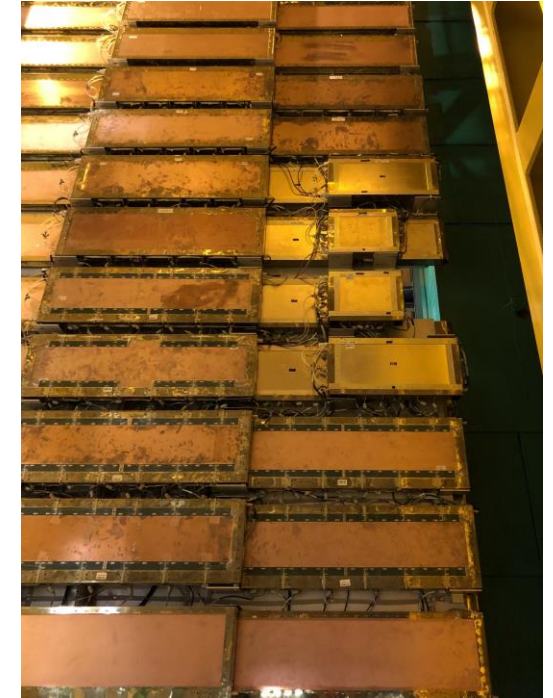
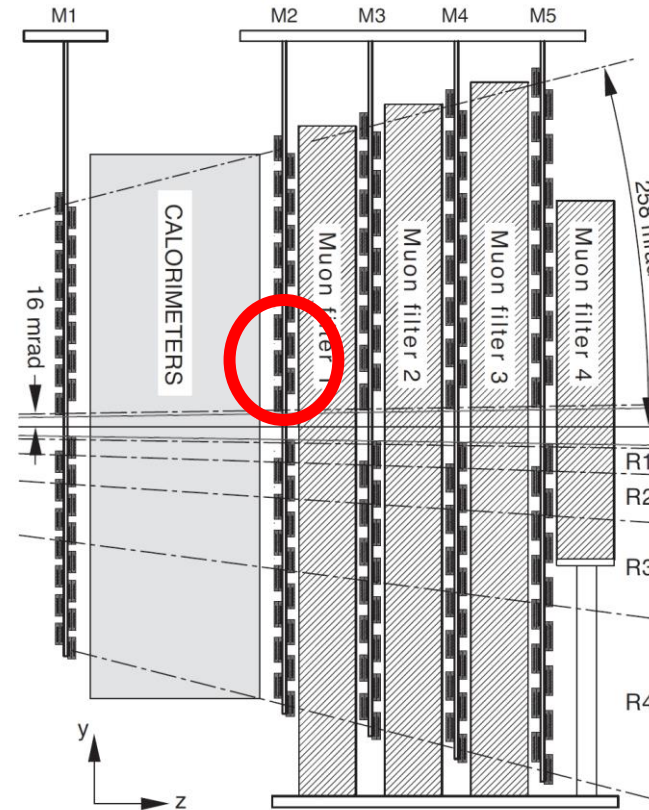
LHCb Muon System:

- 5 stations M1-M5 (Run 1) reduced to 4 M2-M5 in Run 2 and Run 3;
- 4 regions R1-R4;
- 20 chamber types;
- 1368 MWPCs cover 435 m².

Operational information:

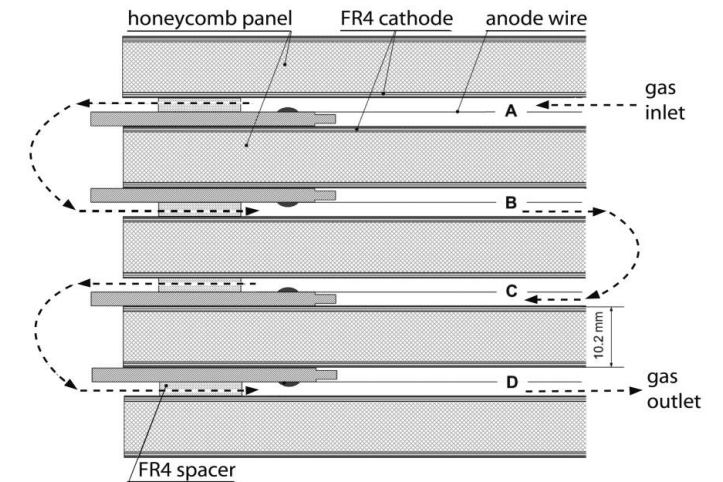
- $L_{\text{instantaneously}} = 4 * 10^{32} \text{ cm}^{-2} * \text{s}^{-1}$
- Operational efficiency >99%;
- More than 13 years of sustained work.

LHCb Collaboration, LHCb muon system: Technical Design Report, Geneva : CERN, 2001. - 89 p.



Design of MWPC (M2-M5)

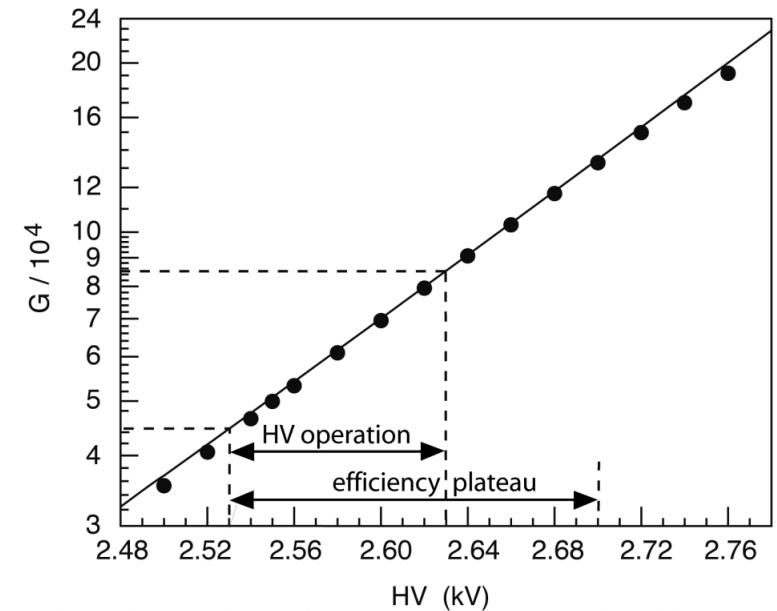
- ❑ 4 High Voltage independent gaps (A-D) per chamber;
- ❑ **Cathod**: fiber-glass plates (FR4) + 35 μm copper coating;
- ❑ **Anode**: 30 μm tungsten wires;
- ❑ Gap-structures divided by **honeycomb** planes;
- ❑ **OR**-ed readout;
- ❑ 40% *Ar* + 55% *CO2* + 5% *CF4* gas mixture;



Internal structure of MWPC

LHCb Muon Gas System

- ❑ 40% *Ar* + 55% *CO2* + 5% *CF4* gas mixture¹;
- ❑ *CF4*:
 - prevents the formation of Si-deposits during MWPC operation;
 - provides to suppress an effect of Malter-like currents;
- ❑ Operations on Efficiency plateau: **2.53-2.63 kV**;
- ❑ Gas Gain coefficient on Efficiency plateau: **$4.4 \cdot 10^4 - 8.6 \cdot 10^4$** ;



Gas gain as a function of Voltage in the LHCb Muon MWPCs²

1. **Werner Riegler**, *Detector physics and performance: simulations of the MWPCs for the LHCb muon system*, LHCb-2000-060.
2. **E. Dané, G. Penso, Davide Pinci, A. Sarti**, *Detailed study of the gain of the MWPCs for the LHCb muon system*, NIM A, Volume 572, Issue 2, 11 March 2007, Pages 682-688.

MWPC Initial conditions

- ❑ **General training procedure** – ... increasing of voltage to the nominal one step by step and controlling the value of currents on gaps under training;
- ❑ $V_{\text{pos}}(\text{max}) = 2.85 \text{ kV}$, $I_{\text{max}} < 0.010 \text{ uA}$;
- ❑ $V_{\text{neg}}(\text{max}) = 2.30 \text{ kV}$, $I_{\text{max}} < 0.150 \text{ uA}$;

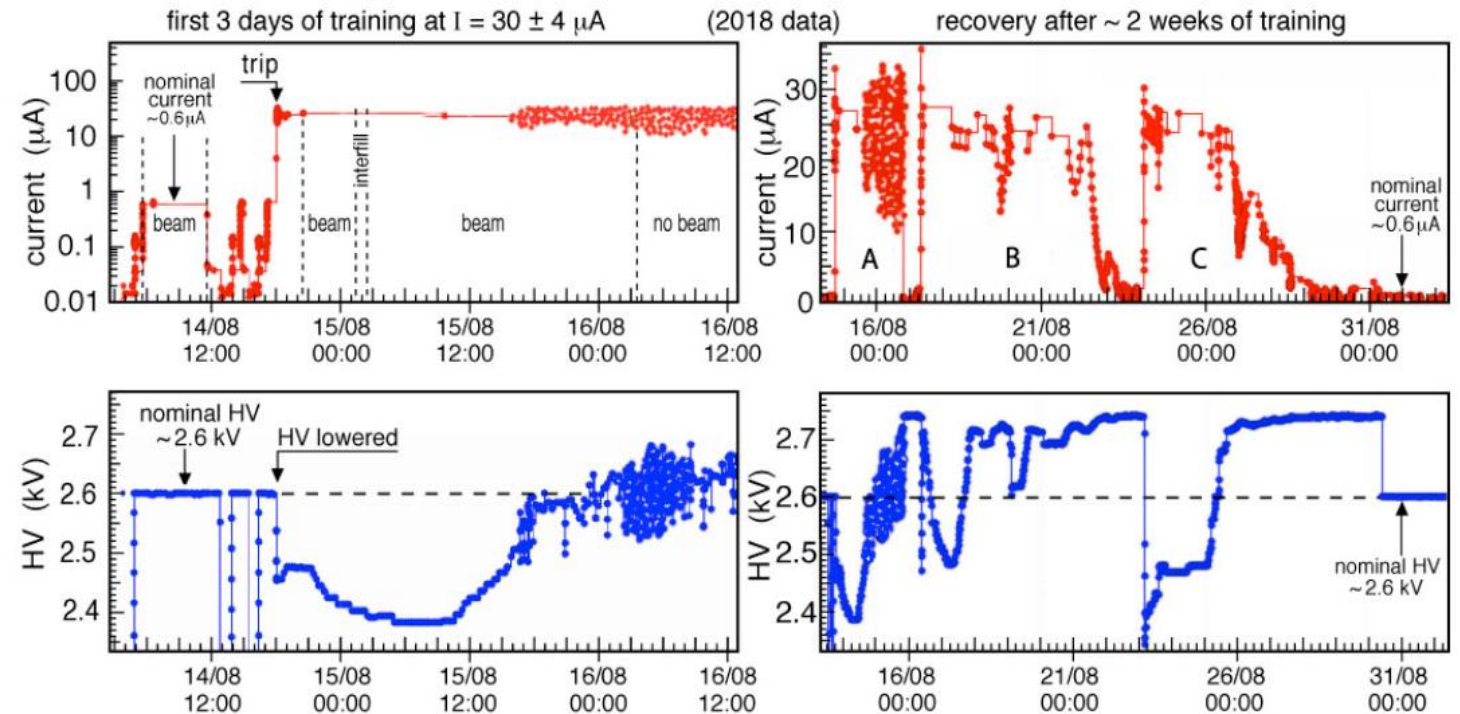
- ❑ **Additional training procedure** for R1/R2 chambers on Gamma Irradiation Facility*;
- ❑ $V_{\text{pos}}(\text{max}) = 2.75 \text{ kV}$
- ❑ $t_{\text{irr.}} = 48 \text{ hours}$;
- ❑ $q_{\text{deposited}} = 1 \text{ mC/cm}$.

1. **V. Souvorov et al.**, First results of an aging test of a full scale MWPC prototype for the LHCb muon system, Nucl. Instrum. Meth. A 515 (2003) 220.
2. **S. Agosteo et al.**, A facility for the test of large-area muon chambers at high-rates, Nucl. Instrum. Meth. A 452 (2000) 94.
3. **J.-S. Graulich et al.**, Conditioning of MWPCs for the LHCb Muon System, NSS/MIC IEEE 2005Conference Record.

Effectiveness of training procedure

Status of malfunctioned MWPCs:

- ❑ Reduces of gas gain have not been observed;
- ❑ The effect of high **self-sustained currents** has been detected in ~ 100 MWPCs gaps per each year;
- ❑ **A higher current increases the concentration of fluorine radicals, produced by CF₄, which react with deposits (silicone, polymers), leading to surface etching by means of the creation of volatile products in the plasma;**
- ❑ The procedure of training provides to restore the functionality of MWPC gap affected by Malter-like currents.



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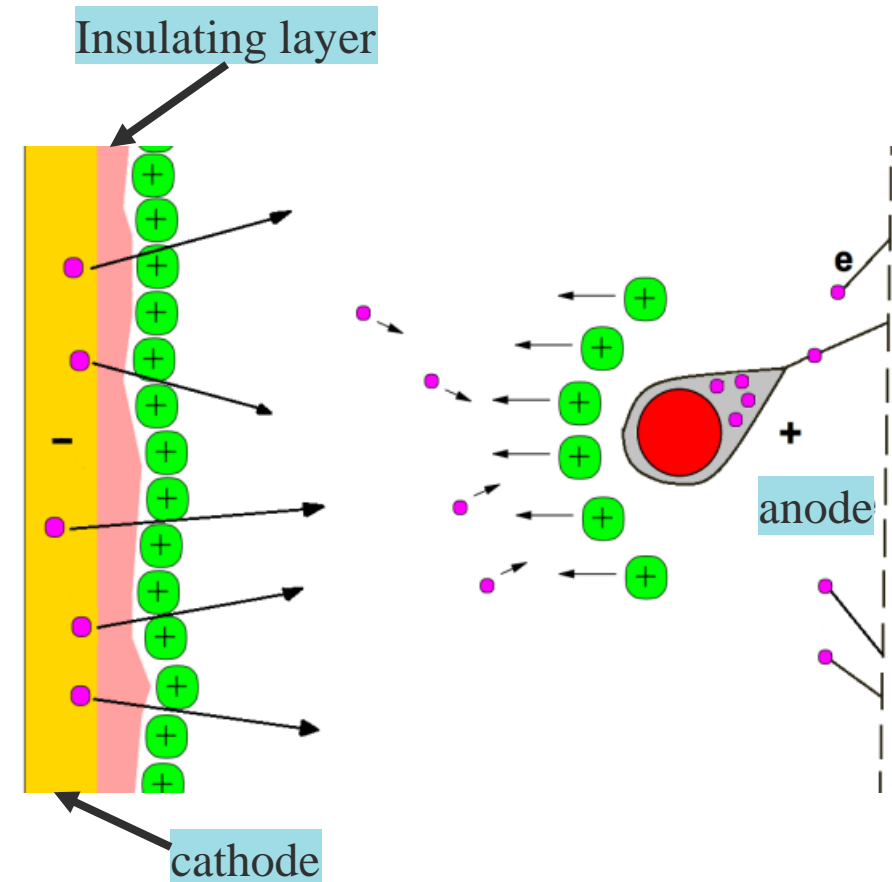
Malter Effect

Malter Current Effect is secondary electron emission which appears when:

1. an insulating layer exists on the cathode;
2. the rate of ion build-up is higher than its removal from the insulating layer;
3. some ignition mechanism take place .

Manifestation of Malter Current Effect:

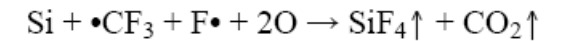
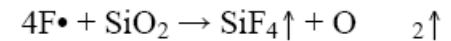
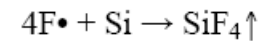
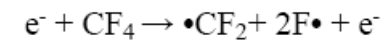
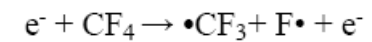
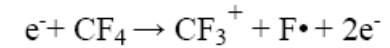
1. self-sustained discharge ignited by high intensity irradiation and micro sparks;
2. sustained μA current independent from external irradiation.



J. Va'vra, DESY workshop, October 2, 2001

Curing Malter-like effects in MWPC in presence of CF₄

- ❑ Polyurethane foam is injected between two mold planes forming the cathode surface on the stage of MWPC production;
- ❑ A mold release agent (ACMOIL36-4600) contains 5-10% silicone;
- ❑ This product is suspected to create patches of insulating film on the cathode surface^{1,2};
- ❑ Dissociation process of CF₄ provides to cure the ME. Free radicals of CF₄ dissociation are produced around anode wires at the electric field 20 –200 kV/cm;
- ❑ The radicals CF₃, •CF₂, F• react with different silicon formations.
- ❑ Formed molecules of CO₂, O₂ and SiF₄ are removed from the detector volume by the gas flow;
- ❑ **The formation process is ongoing around anode wires. The concentration of free radicals is low around the cathod!**



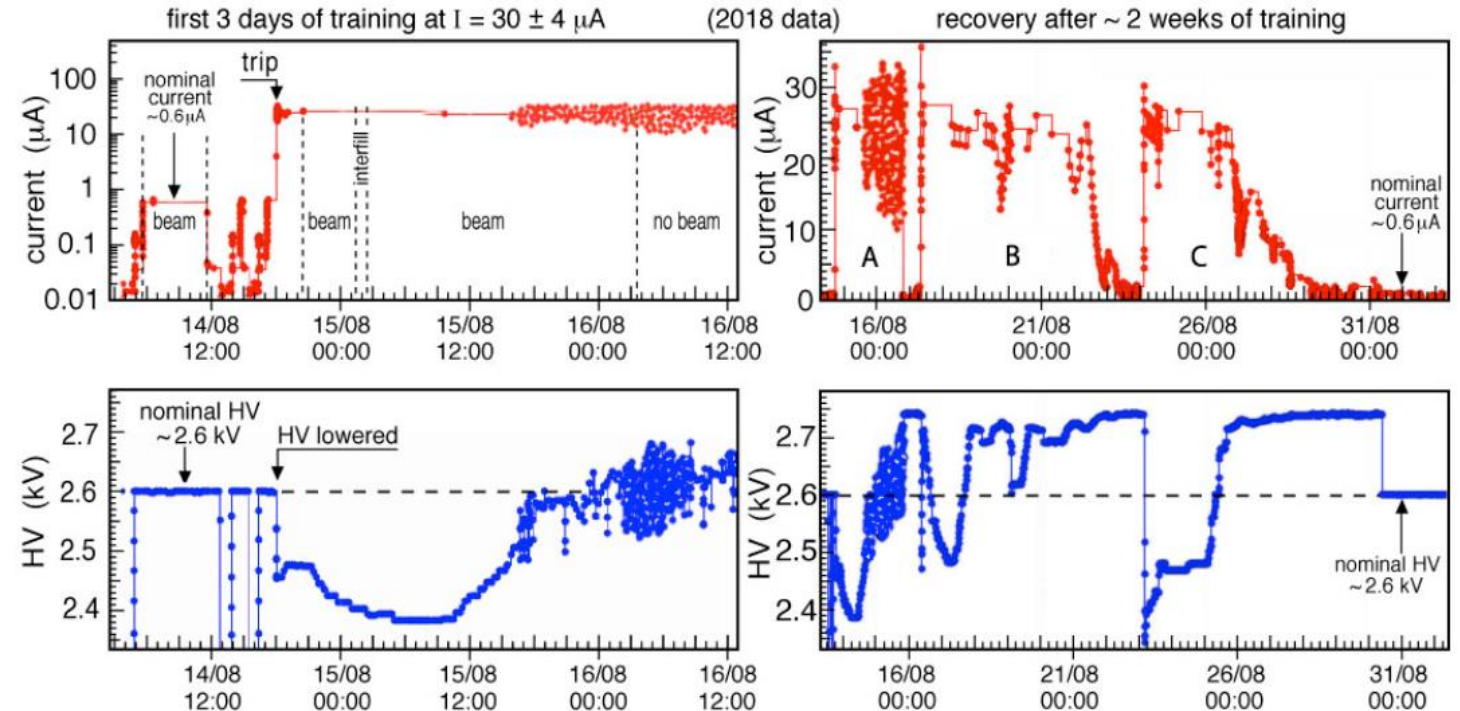
The training process requires a lot of time

1. M. Capeans, Aging and materials: lessons for detectors and gas systems, Nucl. Instrum. Meth. A 515 (2003) 73.
2. S. Belostotski et al., Extension of the operational lifetime of the proportional chambers in the HERMES spectrometer, Nucl. Instrum. Meth. A 591 (2008) 353.
3. F.P. Albicocco et al 2019 JINST 14 P11031

Training procedure

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- ❑ MWPC Type: M5R3
- ❑ **Operation conditions:**
 - ❑ Beam: $V = 2.6$ kV, $I \leq 0.6$ μ A;
 - ❑ No beam: $I \sim 0$ μ A;
- ❑ **Affected conditions:** $V = 2.6$ kV, $I > 30$ μ A;
- ❑ Training procedure:
 - ❑ Decreasing the voltage to safe limit: $I_{lim}=30$ μ A with $\Delta I = 4$ μ A;
 - ❑ **Ramping voltage up/down step by step to hold the current is around limit I_{lim} ;**
 - ❑ Training process required ~ 2 weeks;
 - ❑ Restored the current values close to the nominal ones.
 - ❑ Nominal values turned back to operational conditions



Phases of training:

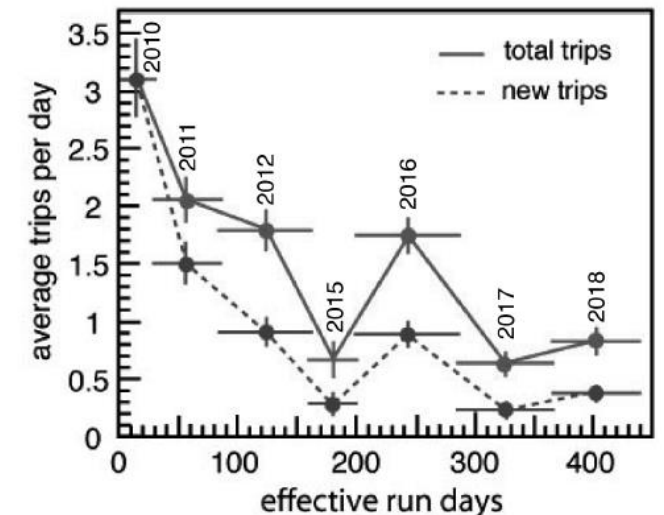
- A. ~ 3 days. Slightly decreasing of Malter-like current, appearing of the current at the end of period;
- B. ~ 7 days. Decreasing of current value during two weeks and it appearing at the end of period;
- C. ~ 7 days. Fully recovered after one (last) week of training.

Training procedure: statistics

- ❑ Average duration of training is around two months (in some cases the procedure required four months);
- ❑ 25-30 gaps go through the training procedure at the same time (Efficiency loss is less than 1%);
- ❑ 375/ 4944 gaps were affected by Malter-effect and have been treated;
- ❑ 27/375 haven't been restored;
- ❑ Most of self-sustained currents appeared during the luminosity ramping-up phase;
- ❑ No correlation with particle flux and integrated luminosity.

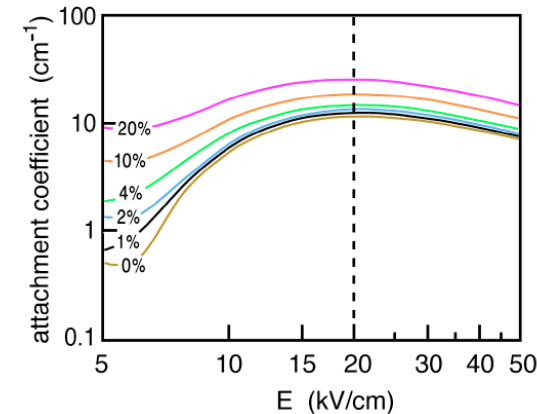
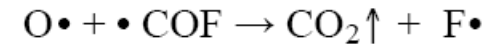
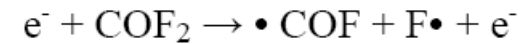
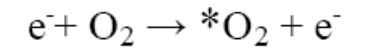
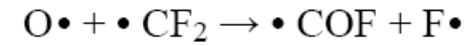
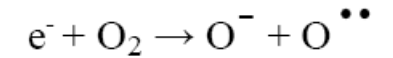
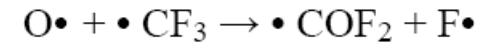
Year	2010	2011	2012	2015	2016	2017	2018	Total
Effective run days	29	56	76	39	86	80	72	438
L_{int} (pb^{-1})	40	1220	2210	370	1910	1990	2460	10200
L_{peak} ($10^{32} \text{ cm}^{-2} \text{ s}^{-1}$)	1.7	3.8	4.0	3.5	3.7	3.5	4.4	—
New trips	90	84	69	11	76	18	27	375
Recurrent trips	0	31	67	15	74	32	32	251

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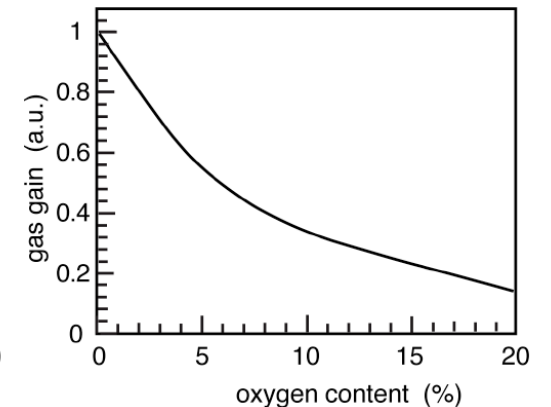


Oxygen recovering: Gas composition for accelerated recovery from Malter effect

- ❑ Etching rate in a CF₄/O₂ mixture is significantly higher in comparison to the one in a pure CF₄ plasma;
- ❑ Oxygen radicals provide to produce the •COFx
- ❑ •COFx quickly dissociates with electrons and atoms and indirectly increases the number of fluorine radicals in the gas discharge plasma;
- ❑ Both oxygen molecules O•• and *O₂ are chemically aggressive and may be used for the etching processes;
- ❑ **O₂ content in MWPC working gas mixture must be optimized** due to reducing of the electron density in discharge plasma;
- ❑ The optimization of O₂ content in LHCb Muon MWPCs was based on a GARFIELD simulation in range of O₂ percentage 0-20%;
- ❑ At 1- 4 % O₂ content the electron attachment coefficient increases only in the drift region (around the cathode surface). While the oxygen content is more than 10%, the electron attachment occurs at the all drift and avalanche regions;
- ❑ The optimized value ~2 %.



Electron attachment coefficient as a function of an electric field



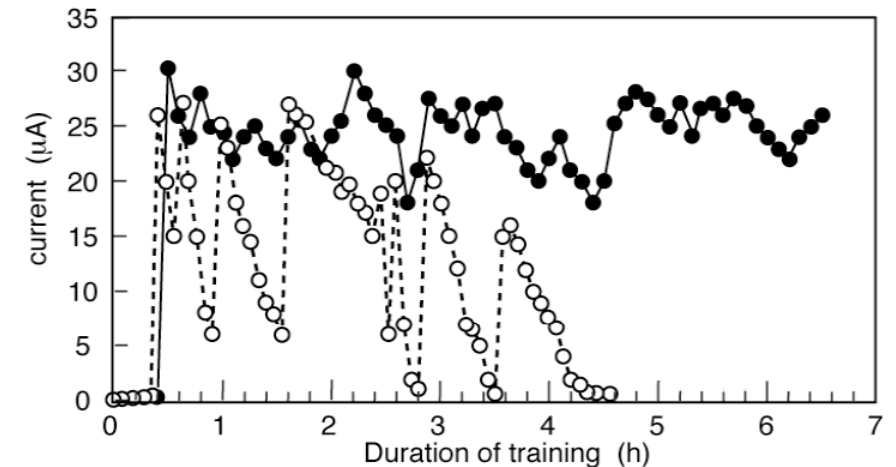
Relative gas gain coefficient as a function of Oxygen content

1. Yu.N. Grigoryev, A.G. Gorobchuk, Numerical Simulation of plasma-chemical reactors, Comput. Technol. 2003. Vol. 8. Special Issue. Pt. 2. P. 53-73.
2. J. Mogab, A. C. Adams, and D. L. Flamm, Plasma etching of Si and SiO₂ - The effect of oxygen additions to CF₄ plasmas, J. Appl. Phys. 49 (1978) 3796.
3. F.P. Albicocco et al 2019 JINST 14 P11031

Oxygen recovering: Accelerated recovery of MWPCs

- ❑ Test the Oxygen recovering on LHCb Muon MWPCs unmounted from the cavern due to the high currents during LHC Long Shutdown 1;
- ❑ HV+ and HV- trainings was not provided the succesfully recovering;
- ❑ Several **“problematic” zones** have been found during MWPCs irradiation by Sr^{90} source;
- ❑ ~7 hours of training procedure use *nominal gas mixture* + Sr^{90} irradiation
- ❑ ~5 hours of training procedure use *oxygen* + *nominal mixture* + Sr^{90} irradiation;
- ❑ All MWPCs gaps have been recovered and mounted back to detector;
- ❑ **Successfully LHCb Muon operations with recovered chambers during Run 2.**

Chamber Type	Number of detected ME zones	ME ignition voltage (kV)	Time for recovery (h)
M2R4	2 (gap A)	2.75	3
		2.8	1
M4R4	1 (gap D)	2.7	5
M5R4	1 (gap A)	2.6	4
	1 (gap B)	2.7	3
	1 (gap D)	2.8	2



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Conclusion

- ✓ LHCb muon detectors did not show a gain reduction or any other apparent deterioration in performance
- ✓ 19% out of 1368 chambers were affected by self-sustained currents;
- ✓ Less than 1% MWPCs have been replaced in 9 years operation;
- ✓ Non-invasive method has been applied to restore the detector efficiency;
- ✓ Tested additional technique of fast restoring by adding an oxygen into gas mixture;
- ✓ The high efficiency of both techniques have been demonstrated.

**Many thanks for your
attention!**

Backup slides

Long-term Operation of the Multi-Wire-Proportional-Chambers of the LHCb Muon System

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<https://arxiv.org/abs/1908.02178>